

AP/1763  
PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Bailey III et al.

Attorney Docket No.:  
LAM1P123/P0557

Application No.: 09/470,236

Examiner: Alejandro Mulero, L.

Filed: November 15, 1999

Group: 1763

Title: PLASMA PROCESSING SYSTEM  
WITH DYNAMIC GAS DISTRIBUTION  
CONTROL

#9 NE  
7/11/01  
mw

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on July 6, 2001.

Signed: \_\_\_\_\_

Ramin Mahboubian

RESPONSE TRANSMITTAL

Commissioner for Patents  
Washington, DC 20231

RECEIVED  
JUL 10 2001  
TC 1700

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

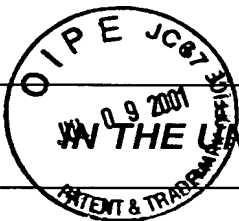
	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	37	MINUS	37	00	x 9 =	x 18 =
Independent Claims	03	MINUS	03	00	x 40 =	x 80 =
Multiple Dependent Claim Present and Fee Not Previously Paid					\$135.00	\$270.00
Total					\$	\$0

- ☐ Applicant(s) hereby petition for a one-month extension(s) of time to respond to the aforementioned Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- ☐ Enclosed is our Check No. \_\_\_\_\_ in the amount of \$\_\_\_\_\_ to cover the additional claim fee and/or extension of time fees.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. LAM1P123).

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP

Ramin Mahboubian  
Reg. No. 44,890

P.O. Box 778  
Berkeley, CA 94704-0778



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Signed: \_\_\_\_\_

Printed Name: Ramin Mahboubian

**RESPONSE AFTER FINAL**

Commissioner for Patents  
Box: AF  
Washington, D.C. 20231

**RECEIVED**  
JUL 10 2001  
**TC 1700**

Dear Sir:

In response to the Final Office Action dated April 10, 2001, please enter the following remarks:

**REMARKS**

In the Final Office Action, the Examiner rejected claims 1-19 as being anticipated by one or more of the U.S. patents: *Moslehi et al.*, *Li et al.*, *Hartig et al.*, and *Ishii et al.* The Examiner also rejected claims 10, 11 and 19-37 under 35 U.S.C. §103(a) in view of